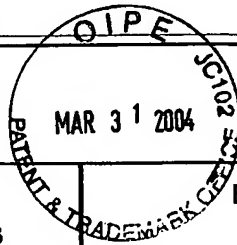


**Change Of Attorney Or Agent's Address In Application  
(37 CFR 1.8(a))**

Docket No.  
3521.181

In Re Application Of: **SOMIT TALWAR, ET AL.**



Serial No.  
10/674,106

Filing Date  
September 29, 2003

Examiner

Group Art Unit  
2813

Invention: **LASER THERMAL ANNEALING OF LIGHTLY DOPED SILICON SUBSTRATES**

**TO THE COMMISSIONER FOR PATENTS**

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